

JUN 03 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
BEFORE THE BOARD OF PATENT APPEALS AND INTERFERENCES

First-Named Inventor: Hoang V. Nguyen
Application No.: 10/023,142 Conf.: 4621
Date Filed: December 18, 2001

Atty Docket No.: NL 000730
Art Unit: 3723
Examiner: Robert A. Rose

Title: Arrangement of a Chemical-Mechanical Polishing Tool and Method of Chemical-Mechanical Polishing

Commissioner for Patents
P.O. Box 1450
Arlington, VA 22313-1450

NOTICE OF APPEAL

Sir:

Applicant(s) hereby appeal(s) to the Board of Patent Appeals and Interferences from the decision dated March 7, 2005 of the Examiner finally rejecting claims 1-37.

- ☒ Please charge the fee of \$330.00 to Deposit Account No. 14-1270.
☐ No additional fee is required, because the fee was paid in a prior appeal.

Please charge any fees which may be required, except the issue fee, or credit any overpayment to Deposit Account No. 14-1270.

Date: 03-JUN-2005

Respectfully submitted,

By

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